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10/561830

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		First Named Inventor	Hayashi, Ryotaro
		Art Unit	Unknown - 27582 DEC 2005
(Multiple sheets used when necessary)		Examiner	Unknown Ponder Thompson - Rummel
SHEET 1 OF 1		Attorney Docket No.	SHIGA7.040APC

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Examiner Signature	/Ponder Thompson Rummel/	Date Considered	08/29/2007
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\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T<sup>1</sup> - Place a check mark in this area when an English language Translation is attached.

<b>Notice of References Cited</b>	Application/Control No.	Applicant(s)/Patent Under Reexamination	
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C	US-			
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